

APPLICATION DATA SHEET

Electronic Version 0.0.11

Stylesheet Version: 1.0

Attorney Docket Number: 740756-2688

Publication Filing Type:

new-utility

Application Type:

utility

Title of Invention:

AN EVALUATION METHOD USING A TEG, A METHOD OF
MANUFACTURING A SEMICONDUCTOR DEVICE HAVING A TEG, AN
ELEMENT SUBSTRATE AND A PANEL HAVING THE TEG, A PROGRAM
FOR CONTROLLING DOSAGE AND A COMPUTER-READABLE
RECORDING MEDIUM RECORDING THE PROGRAM

Legal Representative:

Attorney or Agent:

Jeffrey L. Costellia

Registration Number:

35483

Customer Number Correspondence Address: 22204

22204

Foreign Priority:

2002-364411

JP 2002-12-16

Priority Claimed

Assignee (Publish): Semiconductor Energy Laboratory Co., Ltd.
398, Hase,
Atsugi-shi, 243-0036 Kanagawa-ken JP

INVENTOR(s):

Primary Citizenship: JAPAN

Given Name: Etsuko

Family Name: ASANO

Residence City: Atsugi, Kanagawa

Residence Country: JP

Address: c/o Semiconductor Energy Laboratory Co., Ltd.
398, Hase,
Atsugi-shi, Kanagawa-ken, 243-0036 JP

Primary Citizenship: JAPAN
Given Name: Osamu
Family Name: NAKAMURA
Residence City: Atsugi, Kanagawa
Residence Country: JP
Address: c/o Semiconductor Energy Laboratory Co., Ltd.
398, Hase,
Atsugi-shi, Kanagawa-ken, 243-0036 JP

Primary Citizenship: JAPAN
Given Name: Masayuki
Family Name: SAKAKURA
Residence City: Ebina, Kanagawa
Residence Country: JP
Address: c/o Semiconductor Energy Laboratory Co., Ltd.
398, Hase,
Atsugi-shi, Kanagawa-ken, 243-0036 JP